

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Hujanen et al.
Appl. No.	:	09/997,396
Filed	:	November 28, 2001
For	:	THIN FILMS FOR MAGNETIC DEVICE
Examiner	:	David Vu
Group Art Unit	:	2818

INTERVIEW SUMMARY**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted to provide a summary of a telephonic interview between the Examiner and Applicants' representative.

Summary of Interview begins on page 2 of this paper.

Remarks begin on page 3 of this paper.

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SUMMARY OF INTERVIEW

Exhibits and/or Demonstrations

None.

Identification of Claims Discussed

1, 14, 15, 20, 46 and 52.

Identification of Prior Art Discussed

U.S. Patent No. 6,203,613 to Gates.

Proposed Amendments

Applicants generally proposed amending the claims to indicate that metal oxide is not reduced to elemental metal in each ALD cycle and that after multiple ALD cycles the deposited metal oxide is reduced to elemental metal.

Principal Arguments and Other Matters

Applicants submitted that the proposed amendments would distinguish the adsorption of an oxygen-containing metal precursor and its reduction in each ALD cycle, as disclosed in Gates.

Results of Interview

The Examiner agreed that the proposed amendments would distinguish Gates.

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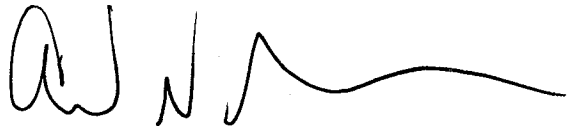
REMARKS

The present paper provides a summary of the telephonic interview held between Andrew Merickel and Examiner Vu on November 14, 2006.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: February 28, 2007

By: 

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